

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant : H. Zhang Art Unit : 2826
Serial No.: 09/804,654 Examiner : F. Abraham
Filed : March 12, 2001
Title : SEMICONDUCTOR DEVICE AND METHOD OF MANUFACTURING THE
SAME

Commissioner for Patents
Washington, D.C. 20231

AMENDMENT

Sir:

In response to the Official Action dated January 3, 2002,
Paper No. 7, in the above-referenced application, kindly
consider the following remarks in connection with the above-
identified application.

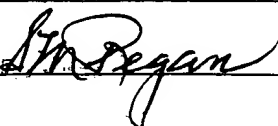
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I hereby certify under 37 CFR §1.8(a) that this correspondence is being
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Susan Regan

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